

ISSUE CLASSIFICATION	
Class	Subclass

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.

PATENT DATE

F.F. SCANNED 103 Q.A. JH

APPLICATION NO. 09/978434	CONT/PRIOR	CLASS 427	SUBCLASS	ART UNIT 1762	EXAMINER <i>Blair</i>
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APPLICANTS

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TITLE

Method of controlling the initial growth of CVD copper films by surface treatment of barrier metals films

PTO-2040
12/99

ISSUING CLASSIFICATION

[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED	
	Sheets Dwg.	Figs. Dwg.	Print Fig.	Total Claims
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner) (Date)		NOTICE OF ALLOWANCE MAILED	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____ _____ _____	_____ (Primary Examiner) (Date)		ISSUE FEE	
			Amount Due	Date Paid
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